

Amendments to the Claims:

This listing of claims replaces all prior versions and listings of claims in the application:

Listing of Claims:

1. (Currently amended) A mask, comprising:
  - a mask substrate;
  - a half-tone layer of half-tone mask material arranged in a pattern across the mask substrate; and
  - a light-blocking layer of light blocking material arranged in a pattern across the half-tone layer;
    - wherein the half-tone mask material is silicon-rich silicon nitride SiNx:H with x in the range 0 to 1, and wherein a thickness of the half-tone layer and x are selected to ~~provided~~ provide a transmittance in the range of 20% to 80%.
2. (Previously Presented) The mask of claim 1 wherein the silicon-rich silicon nitride layer has a value of x in the range 0.2 to 0.6 and an optical band gap of from 2.1eV to 2.5eV.
3. (Previously Presented) The mask of claim 1 wherein the silicon-rich silicon nitride layer has a thickness of from 40nm to 100nm.
4. (Withdrawn) Use of the mask of claim 1 including exposing a layer of photoresist by passing ultra-violet light through the mask onto the layer of photoresist to define fully removed regions in which the photoresist is fully removed, thick regions having a first thickness and thin regions having a thickness less than the first thickness in the regions exposed through the half-tone regions.

9. (Previously Presented) The mask of claim 1 wherein the silicon-rich silicon nitride layer has a value of x in the range 0.2 to 0.5 and an optical band gap of from 2.1eV to 2.35eV.

10. (Previously Presented) The mask of claim 1 wherein the silicon-rich silicon nitride layer has a thickness of 60nm and an optical band gap of 2.3eV.

11. (Previously Presented) The mask of claim 1 wherein the thickness of the half-tone layer and x are selected to provide a transmittance in the range of 40% to 80%.

12. (Previously Presented) The mask as defined in claim 1 wherein variation of the thickness of the half-tone layer is less than or equal to 20%.

13. (New) The mask as defined in claim 1 in which the thickness of the half-tone layer and x are selected to provide a transmittance in the range of 20% to 80% for light having a wavelength in the range of 365 nm to 436 nm.

14. (New) The mask as defined in claim 1, wherein the thickness of the half-tone layer and x are selected to provide a transmittance in the range of 20% to 80% for i-line light having a wavelength of 365 nm, h-line light having a wavelength of 405 nm, and g-line light having a wavelength of 436 nm.